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Laboratory Report

CSE-406: VLSI Circuits Design Laboratory

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Experiment No: 05

Experiment Name: Verification of nMOS and pMOS DC-Characteristics.

Objectives:

- To find the MOS model parameters for the transistors & then by paper and pencil manually calculate the DC characteristics of I_{Ds} current vs V_{GS} voltage using simple current equations for MOS model level 1 to determine the number of corresponding value pairs of (I_{ds}, V_{ds}) with the gate source voltage $V_{GS} = \text{a constant} > V_{th}$.
- Use circuit simulator of Microwind to do a DC simulation of the I_{ds} current vs V_{ds} voltage and the result of the two methods compared.
- Calculation of the threshold voltage.

Theory:

The nMOS transistor I_{ds} current vs V_{ds} voltage equations are as follows:

Cut-off mode: $I_{Ds} = 0$ when $V_{GS} < 0$

Triod/Linear region: $I_{Ds} = K_n \{ (V_{GS} - V_{Tn}) V_{DS} - \frac{1}{2} V_{DS}^2 \}$ when $V_{DS} < V_{GS} - V_{Tn} \dots (1)$

In Level 1 SPICE model, $I_{Ds} = U_O \frac{\epsilon_0 \epsilon_{SiO2}}{TOX} \frac{W}{L} \{ (V_{GS} - V_{Tn}) V_{DS} - \frac{1}{2} V_{DS}^2 \}$

Saturation region: $I_{Ds} = \frac{1}{2} K_n \{ (V_{GS} - V_{Tn})^2 (1 + \lambda V_{DS}) \}$ when $V_{DS} > V_{GS} - V_{Tn} \dots (2)$

In Level 1 SPICE model, $I_{Ds} = \frac{1}{2} U_O \frac{\epsilon_0 \epsilon_{SiO2}}{TOX} \frac{W}{L} \{ (V_{GS} - V_{Tn})^2 \}$

When the channel modulation effect is neglected the drain current equation (2) can be simplified as, $I_{Ds} = \frac{1}{2} K_n \{ (V_{GS} - V_{Tn})^2 \}$ when $V_{DS} > V_{GS} - V_{Tn} \dots (3)$

The current gain factor K_n is constant with unit $[A / V^2]$ This is depended on MOS transistor geometry, fabrication process parameters (electron mobility, μ_n and gate oxide capacitance C_{ox}).

The factor K_n can be calculated as $K_n = K_n' W_n / L_n$ where the process conductance parameter $K_n' = \mu_n C_{ox} [A / V^2]$. The parameter C_{ox} stands for gate oxide capacitance per unit area depend on gate oxide thickness t_{ox} . This can be expressed as $C_{ox} = \epsilon_{0x} / t_{ox}$. The additional parameter of the I_{Ds} and V_{Ds} is the threshold voltage V_{th} .

Procedure:

1. Level 1 MOS model equations to calculate DC values for the drain-current I_{DS} vs drain-source voltage V_{DS} .

Table 1: $V_{GS} = +2.0V$ and $W_n/L_n = 2$

V_{DS} (V)	0.5	1.0	1.5	2.0	2.5
$V_{DS} - (V_{GS} - V_{Tn})$	-1.05	-0.55	-0.05	0.45	0.95
	(1)	(1)	(1)	(2)	(2)
Manual Calculation I_{DS} (micro amp.)	547.56	884.52	1010.88	1011.933	1011.933

2. Use of “simulate>MOS characteristics” to generate the DC characteristics I_{DS} vs V_{DS} for the nMOS transistor in Microwind.

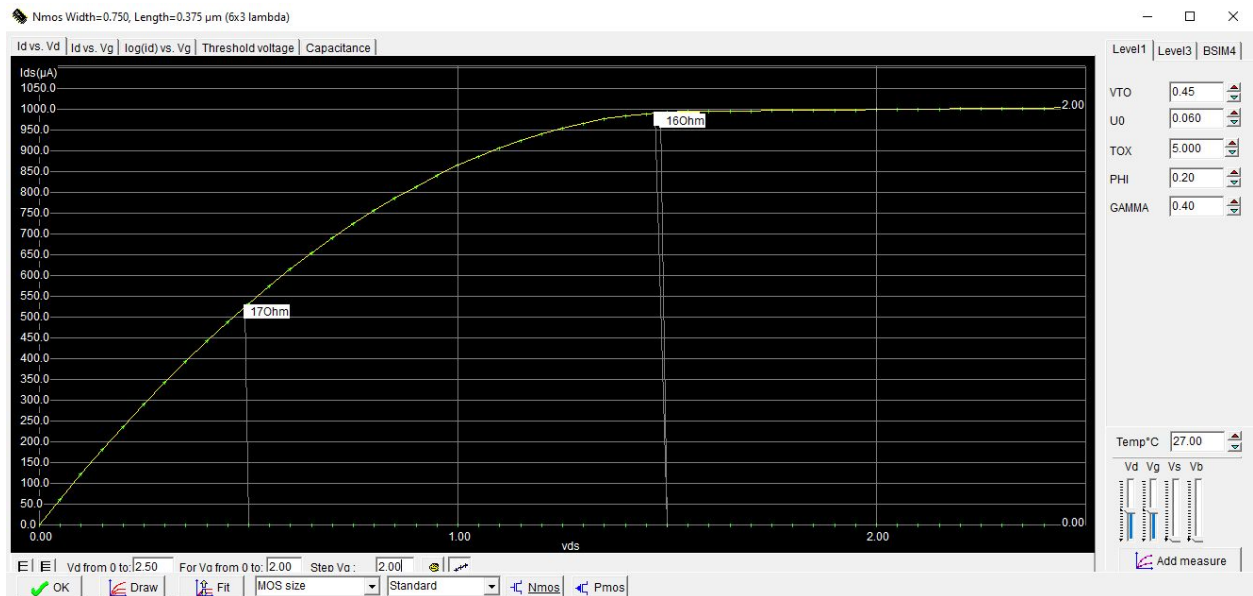


Figure 1: nMOS characteristics curve(simulated)

Result:

The lab objectives are successfully observed and verified with theoretical calculation.